

Notice of References Cited	Application/Control No. 10/524,758		Applicant(s)/Patent Under Reexamination AOYAMA ET AL.	
	Examiner Nathan Bloom		Art Unit 2624	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,538,691	03-2003	Macy et al.	348/222.1
*	B	US-5,048,102	09-1991	Tararine et al.	382/300
*	C	US-2002/0196472	12-2002	Enomoto, Jun	358/3.26
*	D	US-2003/0020732	01-2003	Jasa et al.	345/645
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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	U	Nijmeijer et. al., "Correction of Lens-Distortion for Real-Time Image Processing Systems", Proceedings of the 1993 IEEE Workshop on VLSI Signal Processing, Veldhoven, The Netherlands, October 1993, pages 316-324
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.